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PTO/SB/08A (10-01)

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Sheet | 1 of 2

Substitute for form 1449A/PTO

Complete if Known			
Application Number	09,693,012		
Filing Date	10/19/2000		
First Named Inventor	Bovers		
Art Unit	1746		
Examiner Name			
Attomey Docket Number	101900		

			U.S. PAT	ENT DOCUMENTS	
Examiner Initials		Document Number Number - Kind Code ² (if known	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
Su	A16	us- 6,273,108 B1 us- us-	08-14-2001	Bergman et al	
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Examiner Initials	Cite No. ¹	Foreign Patent Document Country Code 3 - Number 4 - Kind Code 5 (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Ţ¢
(4)	A17	WO 00/70656	11-23-2000	Christenson et al.		
	A18	110 00/1000/	_11-23-2000	Nelson et al		
V	A19	JP058496A2	_2-25-2000	Takashi		
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Examiner Date 1/13/03 Signature le Considered

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Complete if Known Substitute for form 1449B/PTO 09,693,012 Application Number INFORMATION DISCLOSURE 10/19/2000 Filing Date STATEMENT BY APPLICANT First Named Inventor **Boyers** Group Art Unit 1746 (use as many sheets as necessary) Examiner Name 101900 of Attorney Docket Number 2 Sheet

OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T2		
Gn	B39	CHEN, G.S.;, "The Application of DI-O3 Water on Wafer Surface Preparation," International Conference on Wafer Rinsing, Water Reclamation, and Environmental Technology for Semiconductor Manufacturing, 1999 pp. 100-123, Publisher: Industrial Technology Reseach Institute, Hsin-Chu, Taiwan.			
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